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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
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10/671,854

09/25/2003

Stefan Bader

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9645

7590

01/03/2005

COHEN, PONTANI, LIEBERMAN & PAVANE

Suite 1210

551 Fifth Avenue

New York, NY 10176

EXAMINER

TRAN, MINH LOAN

ART UNIT

PAPER NUMBER

2826

DATE MAILED: 01/03/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

Office Action Summary

Application No.

10/671,854

Applicant(s)

BADER ET AL.

Examiner

Minh-Loan T. Tran

Art Unit

2826

-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --
Period for Reply

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

Status

- 1) ☒ Responsive to communication(s) filed on 13 October 2004.
- 2a) ☐ This action is **FINAL**. 2b) ☒ This action is non-final.
- 3) ☐ Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

Disposition of Claims

- 4) ☒ Claim(s) 1-45 is/are pending in the application.
- 4a) Of the above claim(s) 3-5, 12 and 24-45 is/are withdrawn from consideration.
- 5) ☐ Claim(s) _____ is/are allowed.
- 6) ☒ Claim(s) 1, 2, 6-11 and 13-23 is/are rejected.
- 7) ☐ Claim(s) _____ is/are objected to.
- 8) ☐ Claim(s) _____ are subject to restriction and/or election requirement.

Application Papers

- 9) ☒ The specification is objected to by the Examiner.
- 10) ☒ The drawing(s) filed on 25 September 2003 is/are: a) ☐ accepted or b) ☒ objected to by the Examiner.
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).
- 11) ☐ The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.

Priority under 35 U.S.C. § 119

- 12) ☒ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
- a) ☒ All b) ☐ Some * c) ☐ None of:
1. ☒ Certified copies of the priority documents have been received.
 2. ☐ Certified copies of the priority documents have been received in Application No. _____.
 3. ☐ Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).

* See the attached detailed Office action for a list of the certified copies not received.

Attachment(s)

- 1) ☒ Notice of References Cited (PTO-892)
- 2) ☐ Notice of Draftsperson's Patent Drawing Review (PTO-948)
- 3) ☒ Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08)
Paper No(s)/Mail Date 9/25/03.
- 4) ☐ Interview Summary (PTO-413)
Paper No(s)/Mail Date. _____.
- 5) ☐ Notice of Informal Patent Application (PTO-152)
- 6) ☐ Other: _____.

DETAILED ACTION

Election/Restrictions

1. Applicant's election without traverse of Group I, claims 1-23, 36-42 in the reply filed on 10/13/2004 is acknowledged. Further, in response to the election of species, Applicants elect the species of figure 6E. Applicants specify that claims 1, 2 and 4-23 are readable on figure 6E. Actually, only claims 1, 2, 6-11, 13-23 are readable on the elected species (figure 6E), because figure 6E discloses that the mirror 40, which is arranged between the semiconductor stack 1 and the base 50, has a plurality of planar reflection sub-surfaces 14. Thus, claims 3-5, 12 and 24-45 are withdrawn from consideration.

Priority

2. Receipt is acknowledged of papers submitted under 35 U.S.C. 119(a)-(d), which papers have been placed of record in the file.
3. The Preliminary Amendment filed on 03/08/2004 has been entered.

Information Disclosure Statement

4. The information disclosure statement filed on 09/25/2003 has been considered.

Oath/Declaration

5. The oath or declaration filed on 2/20/2004 is acceptable.

Drawings

6. The drawings are objected to under 37 CFR 1.83(a). The drawings must show every feature of the invention specified in the claims. Therefore, the mirror layer 40 includes a plurality of different layers as recited in claim 7; the highly reflective layer 41,

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the protective layer 42 and a joining layer 43 as recited in claims 8-11; the electrically insulating material 19 as recited in claim 18 must be shown or the feature(s) canceled from the claim(s). No new matter should be entered.

7. The drawings are objected to as failing to comply with 37 CFR 1.84(p)(4) because reference character 13 has been used to designate both p-type layer and mirror layer as showed in figure 6E.

Corrected drawing sheets in compliance with 37 CFR 1.121(d) are required in reply to the Office action to avoid abandonment of the application. Any amended replacement drawing sheet should include all of the figures appearing on the immediate prior version of the sheet, even if only one figure is being amended. The figure or figure number of an amended drawing should not be labeled as "amended." If a drawing figure is to be canceled, the appropriate figure must be removed from the replacement sheet, and where necessary, the remaining figures must be renumbered and appropriate changes made to the brief description of the several views of the drawings for consistency. Additional replacement sheets may be necessary to show the renumbering of the remaining figures. The replacement sheet(s) should be labeled "Replacement Sheet" in the page header (as per 37 CFR 1.84(c)) so as not to obstruct any portion of the drawing figures. If the changes are not accepted by the examiner, the applicant will be notified and informed of any required corrective action in the next Office action. The objection to the drawings will not be held in abeyance.

Specification

8. The disclosure is objected to because of the following informalities:

On page 18, line 10, "p-conducting semiconductor layer 11" should be changed to -p-conducting semiconductor layer 13—according to figure 6E.

Appropriate correction is required.

Claim Rejections - 35 USC § 102

9. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless –

(a) the invention was known or used by others in this country, or patented or described in a printed publication in this or a foreign country, before the invention thereof by the applicant for a patent.

Claims 1, 6, 21-23 are rejected under 35 U.S.C. 102(a) as being anticipated by Shibata et al. (6,531,719).

With regard to claim 1, figure 11 of Shibata et al. discloses a semiconductor chip 50 which emits electromagnetic radiation having an epitaxially produced semiconductor stack (16,17,18) based on nitride semiconductor material, which includes an n-GaN layer 16, a p-GaN layer 18, and an electromagnetic radiation generating region 17 which is arranged between these two semiconductor layers 16, 18; a base layer (15,11) on which the semiconductor stack (16, 17, 18) is arranged; and a TiN mirror layer 25 which is arranged between the semiconductor layer stack (16,17,18) and the base layer (15,11) and reflects electromagnetic radiation emitted by the semiconductor stack (16,17,18) in the direction of the base layer (15,11); wherein the mirror layer 25 has a plurality a planar reflection sub-surfaces which are positioned obliquely with respect to a main plane of the radiation-generating region 17 and each form an angle between 10° and 50° with this plane.

With regard to claim 6, figure 11 of Shibata et al. shows the mirror 25 having the reflection sub-surfaces form pyramid-like structures.

With regard to claim 21, Applicant's claim 21 does not distinguish over the Shibata et al. reference regardless of the process used to form the semiconductor chip because only the final product is relevant, not the process of making such as "a growth substrate wafer is at least partially removed after the epitaxially produced semiconductor stack has been grown."

Note that a "product by process" claim is directed to the product per se, no matter how actually made, In re Hirao, 190 USPQ 15 at 17 (footnote 3). See also In re Brown, 173 USPQ 685; In re Luck, 177 USPQ 523; In re Fessmann, 180 USPQ 324; In re Avery, 186 USPQ 161; In re Wertheim, 191 USPQ 90 (209 USPQ 554 does not deal with this issue); and In re Marosi et al., 218 USPQ 289, all of which make it clear that it is the patentability of the final product per se which must be determined in a "product by process" claim, and not the patentability of the process, and that an old or obvious product produced by a new method is not patentable as a product, whether claimed in "product by process" claims or not. Note that applicant has the burden of proof in such cases, as the above caselaw makes clear. See also MPEP 706.03(e).

With regard to claim 22, lines 44-47 in column 4 of Shibata et al. disclose the p-type semiconductor layer is doped with magnesium (Mg).

With regard to claim 23, lines 25-32 in column 4 of Shibata et al. disclose the base (15,11) contains gallium arsenide.

Claim Rejections - 35 USC § 103

10. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negated by the manner in which the invention was made.

Claims 2, 7-11, 19, 20 are rejected under 35 U.S.C. 103(a) as being unpatentable over Shibata et al. (6,531,719).

With regard to claim 2, figure 11 of Shibata et al. discloses all the subject matter claimed except for the p-conducting semiconductor layer faces the base and the mirror is formed by means of a reflection surface of the p-conducting semiconductor layer. However, it would have been obvious to one of ordinary skill in the art to replace the n-type layer 16 of Shibata et al. to the p-type layer, and the p-type layer 18 of Shibata et al. to the n-type layer because the n-type layer and the p-type layer can be interchanged. Note figures 8 and 17 of Hosoba et al. are cited to support for the well known position. Further, Applicant's claim 2 does not distinguish over the Shibata et al. reference regardless of the process used to form the mirror layer because only the final product is relevant, not the process of making such as "the mirror layer (40) is formed by means of a reflection surface (131) of the p-conducting semiconductor layer (13)".

Note that a "product by process" claim is directed to the product per se, no matter how actually made, In re Hirao, 190 USPQ 15 at 17 (footnote 3). See also In re Brown, 173 USPQ 685; In re Luck, 177 USPQ 523; In re Fessmann, 180 USPQ 324; In re Avery, 186 USPQ 161; In re Wertheim, 191 USPQ 90 (209 USPQ 554 does not deal

with this issue); and In re Marosi et al., 218 USPQ 289, all of which make it clear that it is the patentability of the final product per se which must be determined in a "product by process" claim, and not the patentability of the process, and that an old or obvious product produced by a new method is not patentable as a product, whether claimed in "product by process" claims or not. Note that applicant has the burden of proof in such cases, as the above caselaw makes clear. See also MPEP 706.03(e).

With regard to claims 7-11, figure 11 of Shibata et al. does not show the mirror layer 25 having a plurality of different layers such as highly reflective layer, a protective layer and a joining layer. However, it would have been obvious to one of ordinary skill in the art to form the mirror layer of Shibata et al. having a plurality of different layers such as highly reflective layer, a protective layer and a joining layer in order to obtain a maximum efficiency of the emitted light.

With regard to claims 19 and 20, figure 11 of Shibata et al. shows the transparent electrode 19 is formed on the p-GaN layer 18, but it does not show the transparent electrode is formed on the n-type layer. However, it would have been obvious to one of ordinary skill in the art to replace the n-type layer 16 of Shibata et al. to the p-type layer, and the p-type layer 18 of Shibata et al. to the n-type layer because the n-type layer and the p-type layer can be interchanged. Note figures 8 and 17 of Hosoba et al. are cited to support for the well known position. Further, it would have been obvious to one of ordinary skill in the art to form the transparent electrode layer of Shibata et al. that is made of ITO or ZnO because such material is conventional in the art for forming the radiation-transmitting electrically conductive contact layer.

Claims 13-18 are rejected under 35 U.S.C. 103(a) as being unpatentable over Shibata et al. (6,531,719) in view of Shibata et al. (6,342,404).

With regard to claims 13 and 18, figures 1, 2, 11 of Shibata et al. ('719) do not show the semiconductor stack (16,17,18) includes at least one trench which defines a plurality of individual semiconductor layer elements. However, figures 1E, 2, 3, 6 of Shibata et al. ('404) shows the GaN semiconductor stack (26,27,28) includes at least one trench that is filled with an electrically insulating material 6 which transmits radiation generated by the radiation generating region 17; wherein the electrically insulating material 6 defines a plurality of individual semiconductor layer elements 5 (or 22). It would have been obvious to one of ordinary skill in the art to form the semiconductor stack (16,17,18) of Shibata et al. ('719) includes at least one trench which defines a plurality of individual semiconductor layer elements such as taught by Shibata et al. ('404) in order to simplify the processing steps of forming a plurality of light emitting devices.

With regard to claim 14, figures 1E, 2 and 3 of Shibata et al. ('404) show a plurality of trenches that are filled with electrically insulating material 6 extends in such a manner that the semiconductor layer elements 5 (or 22), in plan view, are in the shape of a quadrilateral.

With regard to claim 15, figure 11 of Shibata et al. ('719) shows the semiconductor layer elements 50 each has a width which includes at most 10 pyramid-like structures at the mirror layer 25.

With regard to claim 16, figure 6 of Shibata et al. ('404) shows the trenches that are filled with electrically insulating material 6 are at least sufficiently deep for them to isolate at least the radiation generating region 17.

With regard to claim 17, figures 1E and 6 of Shibata et al. ('404) do not disclose the width of the trenches that are filled with electrically insulating material 6 is at least double the depth of the trenches. However, it would have been obvious to one of ordinary skill in the art to form the width of the trenches Shibata et al.'s reference that are filled with electrically insulating material 6 is at least double the depth of the trenches, in order to ensure that the semiconductor layer elements 5 (or 22) are isolated.

Conclusion

11. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Minh-Loan T. Tran whose telephone number is (571) 272-1922. The examiner can normally be reached on Monday-Friday 9:00 AM-5:30 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nathan J. Flynn can be reached on (571) 272-1915. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

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Minh-Loan T. Tran
Primary Examiner
Art Unit 2826